

MAIL STOP AF
RESPONSE UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 2851

00862.023098

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

| | | |
|-----------------------------|---|------------------------|
| In re Application of: |) | |
| | : | Examiner: K. Gutierrez |
| YOSHIKAZU MIYAJIMA |) | |
| | : | Group Art Unit: 2851 |
| Application No.: 10/647,376 |) | |
| | : | Confirmation No.: 2042 |
| Filed: August 26, 2003 |) | |
| | : | |
| For: REFLECTION MIRROR |) | |
| APPARATUS, EXPOSURE | : | |
| APPARATUS AND DEVICE |) | |
| MANUFACTURING METHOD | : | March 5, 2007 |

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AFTER FINAL REJECTION

Sir:

In response to the final Official Action mailed January 5, 2007, the
Examiner is respectfully requested to consider and enter the following amendments.